

Docket No.: 1592-0177PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kenji SHINOZAKI

Application No.: 10/577,043

Confirmation No.: 2316

Filed: June 25, 2007

Art Unit: 2813

For: SUBSTRATE PROCESSING APPARATUS
AND SEMICONDUCTOR DEVICE
PRODUCING METHOD

Examiner: D. A. Wolverton

LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

Pursuant to the Notification of Acceptance mailed October 2, 2008 in connection with the above-identified application, enclosed herewith are copies of the **Foreign and/or Non-Patent Literature documents** that were cited in the International Search Report and listed on the Form PTO-SB08 filed with the Information Disclosure Statement on April 24, 2006.

The PTO is requested to make these documents of record in the file of the present application and to return an initialed copy of the enclosed Form PTO-SB08 to the undersigned.

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If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to our Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under § 1.17; particularly, extension of time fees.

Dated: May 27, 2009

Respectfully submitted,

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Attachments: Documents cited in Search Report (6)
PTO Form SB08 (copy)